

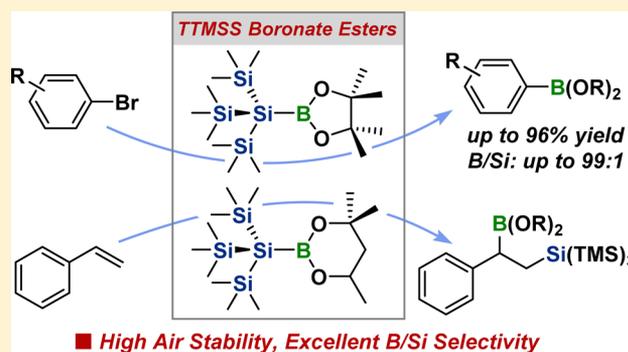
Tris(trimethylsilyl)silylboronate Esters: Novel Bulky, Air- and Moisture-Stable Silylboronate Ester Reagents for Boryl Substitution and Silaboration Reactions

Eiji Yamamoto,[†] Ryosuke Shishido, Tomohiro Seki,[‡] and Hajime Ito^{*†‡}

Division of Applied Chemistry & Frontier Chemistry Center, Graduate School of Engineering, Hokkaido University, Sapporo 060-8628, Japan

Supporting Information

ABSTRACT: New, bulky tris(trimethylsilyl)silylboronate pinacol and hexylene glycol esters ((TMS)₃Si–B(pin) and (TMS)₃Si–B(hg)) were prepared in 46 and 61% yields, respectively, by the reaction of tris(trimethylsilyl)silylpotassium with the corresponding boron electrophiles. Notably, these silylboronate esters exhibited high stability to air and silica gel and were applied to the transition-metal-free boryl substitution of aryl halides, providing the desired borylated products in high yields with excellent B/Si ratios (up to 96% yield, B/Si = 99/1). These new silylboronate esters were also applied to a sequential borylation/cross-coupling process with various aryl halides, as well as the base-mediated silaboration of styrene.



Silylboronate esters such as PhMe₂Si–B(pin) (**1a**) have been widely used as versatile reagents for preparing organoboron and -silicon compounds,¹ both of which are important building blocks in organic chemistry, because the C–B or C–Si bonds can be transformed to various functional groups.^{2,3} We have reported the transition-metal-free boryl substitution of aryl halides with silylboronate ester **1a** and alkoxy base (Base-mediated Borylation with Silylboronate esters, denoted as BBS, **Figure 1a**).^{4,5} This reaction provides facile access to various aryl-, heteroaryl-, and alkenylboronate esters because it can be operated under mild conditions with high reactivity in the absence of a transition-metal catalyst. This BBS strategy can also be used to directly prepare triarylsilanes,

which have numerous potential applications in materials science, from various organic halides.^{4d} However, the application of this strategy has been limited by an unwanted silylation reaction (typical borylation/silylation ratio (90/10)–(96/4)). Furthermore, the silylboronate ester reagents typically used in this strategy (e.g., PhMe₂Si–B(pin)) are unstable to air and moisture. Although there exist several reactions using the silylboronate ester reagent in the presence of air or water, significant decomposition of silylboronate esters after storage of the reagents in air is usually observed.⁶

Mechanistic studies have suggested that this reaction proceeds via the halogenophilic attack of a silicon nucleophile on the halogen atom of an aryl halide, forming the corresponding aryl anion intermediate. The subsequent nucleophilic attack of the aryl anion determines the borylation/silylation (B/Si) ratio of the products (**Figure 1a**, path a or b). On the basis of this mechanism, we envisioned that the use of silylboronate esters bearing a bulky silyl group would improve the B/Si selectivity of the BBS by suppressing the undesired pathway (path b). As for the usability issue of silylboronate ester compounds, PhMe₂Si–B(pin) (**1a**) is sensitive to air and moisture. Although several analogous silylboronate esters^{1,7,8} have been reported, very little is known about the stability of these compounds. Hartwig and co-workers reported the Ir-catalyzed borylation of hydrosilanes and synthesized several trialkylsilylboronate esters, including Et₃Si–B(pin) (**1b**), which they purified by column chromatography over silica gel.⁸ These compounds are fairly stable, but

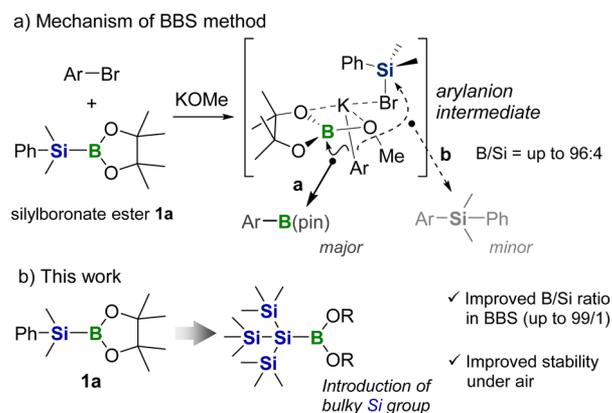


Figure 1. (a) Base-mediated borylation with silylboronate ester. (b) Concept of this work.

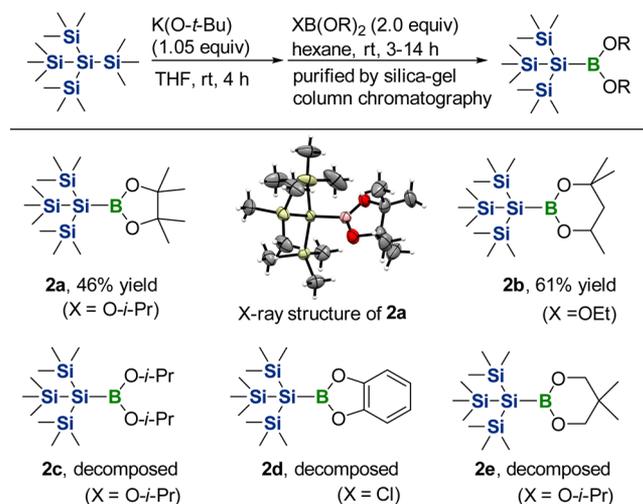
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their reactivity in base-catalyzed reactions was not studied. It is necessary to develop a new silylboronate ester reagent that shows good bench stability as well as excellent reactivity and selectivity in reactions with alkoxy bases. We envision that silylboronate esters bearing considerable steric bulk would be sufficiently stabilized kinetically to tolerate air and moisture (Figure 1b). With this in mind, we focused on the use of a tris(trimethylsilyl)silyl ((TMS)₃Si) group,^{9,10} which is comparable in size to a *tert*-butyl group.^{9b}

Herein, we report the first synthesis of silylboronate esters ((TMS)₃Si–B(OR)₂) bearing a tris(trimethylsilyl)silyl ((TMS)₃Si) group,^{9,10} which show high selectivity in the BBS and silaboration reactions with excellent air/moisture stability. Notably, these silyl boronates were readily purified by column chromatography over silica gel, highlighting their stability. Furthermore, these silylboronate ester reagents were successfully applied to transition-metal-free boryl substitution of aryl halides,⁴ affording the corresponding arylboronates in high yields with high B/Si ratios (up to 99/1). We also conducted the KOMe-mediated silaboration of styrene^{11,12} using silylboronate esters.

We initially explored the synthesis of tris(trimethylsilyl)-silylboronate esters which have different alkoxy substituents on their boron atom (Table 1). Tris(trimethylsilyl)-

Table 1. Synthesis of (TMS)₃Si–B(OR)₂^a



^aReaction conditions: a mixture of (TMS)₄Si (1.0 equiv) and K(*O*-*t*-Bu) (1.05 equiv) in THF (0.50 M to (TMS)₄Si) was stirred for 4 h at room temperature. The reaction mixture was concentrated in vacuo, diluted with hexane (0.50 M to (TMS)₄Si), and treated with X–B(OR)₂ (2.0 equiv), before being stirred for 3–14 h. Compounds 2c–e decomposed during column chromatography over silica gel.

silylpinacolborane ((TMS)₃Si–B(pin) (**2a**)) was obtained in 46% yield as a colorless solid using in situ generated tris(trimethylsilyl)silylpotassium and *i*-PrOB(pin). This compound was successfully purified by column chromatography over silica gel. Tris(trimethylsilyl)silylboronic acid hexylene glycol ester ((TMS)₃Si–B(hg), (**2b**)) was also synthesized in the same manner (**2b**, 61% yield, colorless solid). Disappointingly, however, tris(trimethylsilyl)silylboronate esters bearing a diisopropoxy (**2c**), catecholato (**2d**), or neopentylglycolato (**2e**) moiety decomposed during column chromatography over silica gel, although the corresponding silylboronate esters

seemed to be formed in the reaction mixtures on the basis of the GC analyses.

The molecular structure of **2a** was confirmed by single-crystal X-ray analysis (Supporting Information). The Si–B bond length of **2a** (2.015(5) Å) was found to be shorter than that of a *B*-silylborazine bearing a (TMS)₃Si group ((TMS)₃Si–(Me)₂B₃N₃(Me); B–Si length, 2.097(5) Å)^{10a} and even shorter than the sum of the covalent radii of B and Si (2.05 Å). Although (TMS)₃Si is well-known as a bulky group, these comparisons suggest that steric congestion around the Si–B bond is not significant because the substituents around B and Si atoms ((TMS)₃Si and pinacol) are far from each other.

Encouraged by the successful preparation of the (TMS)₃Si boronate esters, we proceeded to evaluate their stability to air (Figure 2). Pleasingly, (TMS)₃Si–B(pin) (**2a**) remained

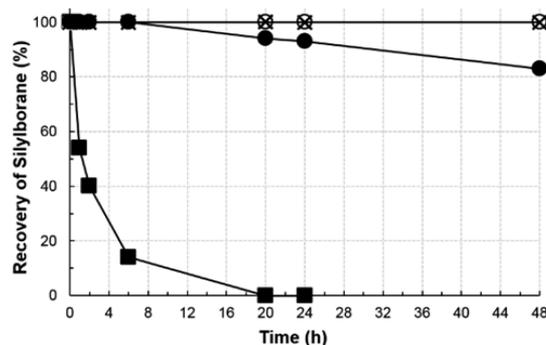
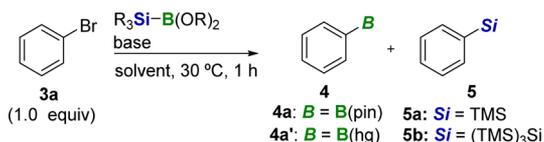


Figure 2. Stability of silylboronate esters under air: (■) PhMe₂Si–B(pin) (**1a**); (×) Et₃Si–B(pin) (**1b**); (○) (TMS)₃Si–B(pin) (**2a**); (●) (TMS)₃Si–B(hg) (**2b**). Conditions: a solution of silylboronate ester **1a**, **1b**, **2a**, or **2b** (0.2 mmol) in toluene (1.0 mL) was stirred at room temperature. After a set time, the recovery of the silylboronate ester was determined by GC.

unchanged after 48 h at room temperature in toluene under air. In contrast, only less than 20% of PhMe₂Si–B(pin) (**1a**) was left after 5 h under the same conditions. (TMS)₃Si–B(hg) (**2b**) also showed greater stability to air than PhMe₂Si–B(pin) (**1a**), although the recovery of **2b** was 83% under the same conditions after 48 h. The stability of Et₃Si–B(pin) (**1b**) was similar to that of **2a**. The stability of silylboronate esters **1a** and **2a,b** to silica gel was also investigated on the basis of their recovery from silica gel swelled with hexane at room temperature under air for 1 h. The results revealed that the stabilities were in the order **2a** > **2b** > **1a** (recovery yields 95%, 85%, and 64%, respectively; for details, see the Supporting Information), which was in good agreement with the stability of these compounds to air.

To investigate the applicability of these silylboronate ester reagents to organic synthesis, we investigated the boryl substitution of phenyl bromide with (TMS)₃Si–B(pin) (**2a**) and (TMS)₃Si–B(hg) (**2b**) (Table 2).⁴ We initially examined the reaction of **2a** with **3a** in the presence of KOMe using DME as a solvent, which afforded the desired product in 63% yield with a B/Si ratio (**4a**:(**5a** + **5b**)) of 89/11 (Table 2, entry 1). The use of silylboronate ester **2b** instead of **2a** led to an improvement in the yield and B/Si ratio (80%, B/Si = 93/7; Table 2, entry 2); thus, all of the subsequent optimization reactions were conducted using **2b**. The use of NaOMe provided results similar to those obtained with KOMe, whereas LiOMe failed to afford the desired products (Table 2, entries 3 and 4). The best results were obtained using the bulky base

Table 2. Optimization of the Reaction Conditions for the Borylation of 3a with (TMS)₃Si-B(OR)₂/Alkoxy Base^a

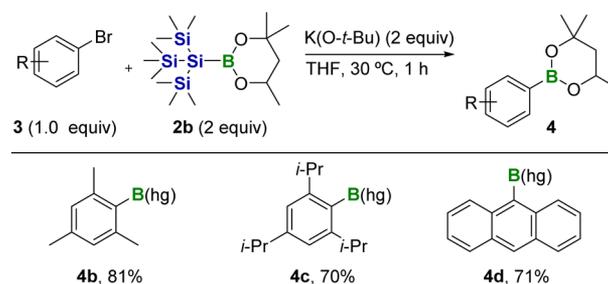
entry	Si-B	base (equiv)	solvent	yield (%) ^b	4/(5a + 5b) ^c
1 ^d	2a	KOMe (2.0)	DME	63	89/11
2	2b	KOMe (2.0)	DME	80	93/7
3	2b	NaOMe (2.0)	DME	80	90/10
4	2b	LiOMe (2.0)	DME	0	
5	2b	K(O- <i>t</i> -Bu) (2.0)	DME	94	98/2
6	2b	Na(O- <i>t</i> -Bu) (2.0)	DME	91	96/4
7	2b	Li(O- <i>t</i> -Bu) (2.0)	DME	75	94/6
8	2b	K(O- <i>t</i> -Bu) (2.0)	THF	95 (76) ^e	96/4
9 ^f	2b	K(O- <i>t</i> -Bu) (1.2)	DME	64	95/5
10 ^g	2b	K(O- <i>t</i> -Bu) (2.0)	DME	62	97/3
11 ^h	2b	K(O- <i>t</i> -Bu) (2.0)	DME	96	99/1
12	1b	K(O- <i>t</i> -Bu) (2.0)	THF	0	

^aReaction conditions unless specified otherwise: silyboronate ester (2 equiv) and a base in a solvent was stirred for 10 min at 650 rpm at 30 °C, after which 3a (0.3 mmol) was added. The resultant mixture was stirred for 1 h at 30 °C. ^bGC yield of 4a or 4a'. ^cRatio of 4a or 4a' to 5a + 5b. ^dReaction time: 3 h. ^eIsolated yield after sequential boryl substitution/Suzuki–Miyaura coupling. ^f1.5 equiv of 2b was used. ^gPhCl was used as a substrate. ^hPhI was used as a substrate.

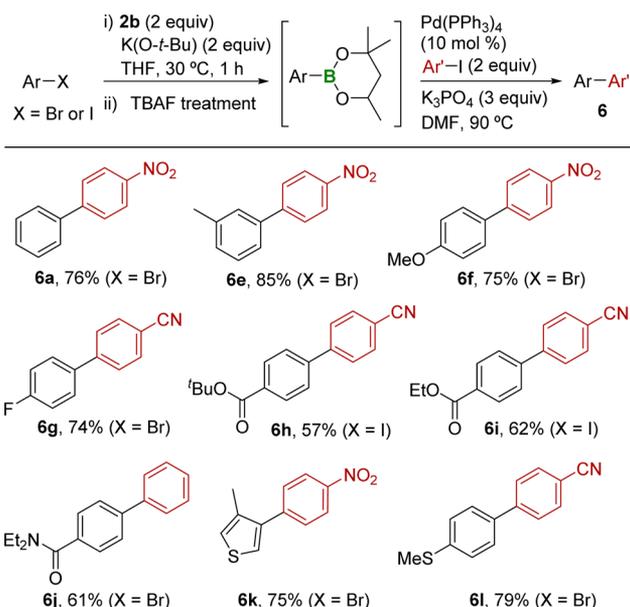
K(O-*t*-Bu) (Table 2, entry 5). Na(O-*t*-Bu) and Li(O-*t*-Bu) also showed better yields and B/Si selectivities than their methoxide counterparts (Table 2, entries 6 and 7). The replacement of DME with THF had very little effect on the yield or selectivity (Table 2, entry 8). We also examined the reaction with 1.5 equiv of 2b, which resulted in a lower yield (64%, B/Si = 95/5; Table 2, entry 9). The effect of the leaving group of the aryl halide was also investigated. Chlorobenzene gave the corresponding borylated product in good yield and high selectivity (62%, B/Si = 97/3; Table 2, entry 10), whereas iodobenzene gave an excellent yield and higher selectivity (96%, B/Si = 99/1; Table 2, entry 11). In contrast, the reaction of bromobenzene with Et₃Si-B(pin) (1b), which shows stability similar to that of 2b, resulted in no reaction (Table 2, entry 12).

With the optimized reaction conditions in hand, we investigated the borylation of hindered aryl bromides with 2b (Table 3). Pleasingly, sterically hindered aryl bromides 3b–d also reacted to give the corresponding products in high yields (4b, 81%; 4c, 70%; 4d, 71%).

We also investigated the possibility of a one-pot borylation/Suzuki cross-coupling sequence to further explore the functional group compatibility of 2b and the overall utility of this reaction (Table 4). Electron-neutral and electron-rich aryl bromides readily underwent the borylation, followed by a cross-coupling with 4-nitroiodobenzene, to provide the corresponding products in high yield (6a, 76%; 6e, 85%; 6f, 75%). Reactions with aryl bromides or iodides bearing an electron-withdrawing group (i.e., fluoro, *tert*-butyl or ethyl ester or amide group) also proceeded smoothly to afford the desired products in good yields (6g, 74%; 6h, 57%; 6i, 62%; 6j, 61%). Notably, two sulfur-containing aryl bromides also underwent the one-pot borylation/cross-coupling to afford the desired products in good yields (6k, 75%; 6l, 79%). 2a,b could also be

Table 3. Substrate Scope for the Boryl Substitution of Aryl Halides using (TMS)₃Si-B(hg)/K(O-*t*-Bu)^a

^aReaction conditions: a mixture of silyboronate ester 2b (2 equiv) and K(O-*t*-Bu) (2.0 equiv) in THF was stirred for 10 min at 650 rpm and 30 °C. Aryl bromide 3 (0.3 mmol) was added, and the resulting mixture was stirred for 1 h at 30 °C.

Table 4. Substrate Scope for the Boryl Substitution of Aryl Halides with (TMS)₃Si-B(hg)/K(O-*t*-Bu)^a

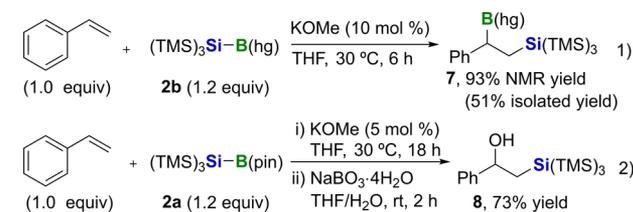
^aIsolated yield.

used as reagents for the base-mediated silaboration of alkenes,¹¹ which can provide access to synthetically useful 1,2-bis-metalated products.

The silaboration of styrene with 2b in the presence of a catalytic amount of KOMe gave the desired silaborated product 7 in high yield (93% NMR yield). Furthermore, the one-pot, base-mediated silaboration of styrene with 2a/NaBO₃ oxidation gave the corresponding alcohol 8 in 73% yield (Scheme 1). In contrast, the reaction of styrene with Et₃Si-B(pin) (1b) in the presence of a catalytic amount of KOMe resulted in no reaction.

In conclusion, we have developed novel air- and moisture-stable TTMS boronate esters. These reagents were stable for extended periods at room temperature in solution and also exhibited good stability to silica gel. Furthermore, these reagents were successfully used in the boryl substitution of aryl halides with K(O-*t*-Bu), as well as the silaboration of styrene in the presence of catalytic KOMe.

Scheme 1. Silaboration of Styrene with Silyl Boronate Ester 2a or 2b in the Presence of KOMe



■ ASSOCIATED CONTENT

Supporting Information

The Supporting Information is available free of charge on the ACS Publications website at DOI: 10.1021/acs.organo- met.7b00476.

Synthetic details, characterization data, and crystallo- graphic data (PDF)

Accession Codes

CCDC 1540097 contains the supplementary crystallographic data for this paper. These data can be obtained free of charge via www.ccdc.cam.ac.uk/data_request/cif, or by emailing data_request@ccdc.cam.ac.uk, or by contacting The Cambridge Crystallographic Data Centre, 12 Union Road, Cambridge CB2 1EZ, UK; fax: +44 1223 336033.

■ AUTHOR INFORMATION

Corresponding Author

*E-mail for H.I.: hajito@eng.hokudai.ac.jp.

ORCID

Tomohiro Seki: 0000-0002-4642-1324

Hajime Ito: 0000-0003-3852-6721

Present Address

†Department of Chemistry, Graduate School of Science, Kyushu University, Fukuoka 819-0395, Japan.

Notes

The authors declare no competing financial interest.

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